## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re Application of

Bojarczuk, et al.

09/755,164 Serial No.:

Group Art Unit:

2826

Filed:

January 8, 2001

Examiner:

Quinto, Kevin V.

For:

ALUMINUM NITRIDE AND ALUMINUM OXIDE/ALUMINUM NITRIDE HETEROSTRUCTURE GATE DIELECTRIC STACK BASED FIELD EFFECT

TRANSISTORS AND METHOD FOR FORMING SAME

Honorable Commissioner of Patents

Box AF

Alexandria, VA 22313 - 1450

## SUPPLEMENTAL AMENDMENT AFTER FINAL REJECTION UNDER 37 C.F.R.

Sir:

This paper is a supplement to the Amendment After Final Rejection that was filed on September 16, 2003 that was responsive to the Office Action dated July 16, 2003. Please amend the above-identified application as follows:

## INTRODUCTORY COMMENTS

Claims 1-7, 14-18, and 28-31 are all the claims presently pending in the application.

Claims 1, 14-15 and 17 have been amended to more clearly define the invention and claims 28-

31 have been added. Claims 1, 14-15 and 17 are independent.